Attorney Docket No. 239/162 DIV.1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

Chul-Sung KIM, et al.

Serial No.

[Division of Serial No. 10/102,997, filed March 22, 2002]

Filed: October 15, 2003

For: METHOD AND DEVICE FOR FORMING AN STI TYPE ISOLATION IN A SEMICONDUCTOR DEVICE

CONFIRMATION
CLAIM FOR CONVENTION PRIORITY

Commissioner for Patents
Alexandria, VA 22313-1450

Sir:

The benefit of the filing date of the following prior foreign application filed in the following foreign country is hereby requested, and the right of priority provided in 35 U.S.C. §119 is hereby claimed:

Application No. 2001-0052396 - filed August 29, 2001 - Republic of Korea

In support of this claim, a certified copy of said original foreign application was filed in parent application Serial No. 10/102,997 on March 22, 2002.

Acknowledgment of applicant's claim for priority and receipt of the certified priority document is solicited.

Respectfully submitted,

Date: October 15, 2003

Eugene M. Lee, Reg. No. 32,039

LEE & STERBA, P.C.
1101 WILSON BOULEVARD, SUITE 2000
ARLINGTON, VA 22209
703.525.0978 TEL
703.525.4265 FAX